



FINEPLACER® femto 2

Automated Prototype2Production Bonder



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The new FINEPLACER® femto 2 is a fully automated sub micron die bonder for advanced packaging applications. A complete machine enclosure ensures highly stable and fully controlled processes with the focus on maximum yield.

Numerous innovations such as the cutting- edge Vision Alignment System *FPXvision™* allow for a highly flexible application spectrum. IPM Command, a new generation of FINEPLACER® operating software, has been designed to ensure a fast, ergonomic and clearly structured process development.

With a modular system architecture, the FINEPLACER® femto 2 can be configured at any time to support a virtually unlimited range of applications and processes. This makes the system a perfect tool and reliable companion as applications migrate from product development to production.

Highlights*

- Placement accuracy 0.5 µm @ 3 sigma
- Fully- automated operation
- Manual operating routines available
- Controlled process environment with cleanroom quality
- Operator protection from emissions (lasers, UV sources, gasses)
- Full process access and quick process setup
- **FPXvision™**: maximum resolution across large field of view
- Ergonomic operating concept with touch screen interface
- Modular design allows individual configurations

Features

- Pattern recognition for automated placement and bonding processes
- High optical resolution across a large object field
- Integrated Process Management (IPM)
- IPM Command: library based operating software of the next generation
- Live process observation
- Virtually unlimited variety of advanced bonding technologies

Benefits

- User independent process operation ensures stability, accuracy and optimal yield
- Outstanding placement accuracy with large components and substrates
- Synchronized control of all process related parameters: force, temperature, time, power, process environment, light and vision
- Fast, modular process development with graphical user interface
- Immediate visual feedback reduces process development time
- Use one system from product development to production

Technologies

- Thermocompression bonding
- Thermosonic bonding
- Ultrasonic bonding
- Soldering (AuSn / eutectic, Indium, C4)
- Adhesive technologies
- UV curing / thermal curing
- Bump bonding
- Copper pillar bonding
- Mechanical assembly

Applications

- Flip chip bonding (face down)
- Precise die bonding (face up)
- Laser diode, laser diode bar bonding
- Optical engines, VCSEL/ photo diode bonding
- LED bonding
- Micro optics assembly
- MEMS/ MOEMS/ sensor packaging
- 3D packaging
- Wafer level packaging (W2W, C2W)
- Chip on glass, chip on flex

Technical Specifications*

Placement accuracy*:	0.5 μm @ 3 sigma
Field of view:	3.8 mm x 2.7 mm
Native camera resolution:	1 μm / pix
Extended field of view:	83 mm x 2,7 mm
Component size (min):	0.05 mm x 0.05 mm
Component size (max):	100 mm x 100 mm
Component thickness ¹ :	0.01 - 10 mm
Substrate size:	on customer request
Substrate thickness (max) ¹ :	35 mm
Theta fine travel / resolution:	$\pm 9^\circ$ / 3.5 μrad
Z- travel / accuracy:	10 mm / 0.2 μm
Y- travel / accuracy:	150 mm / 0.1 μm
X- travel / accuracy:	450 mm / 0.1 μm
Heating temperature ² :	450 $^\circ\text{C}$
Bonding force range*:	0.05 N - 500 N

Modules & Options

- Automatic Tool Changer
- Bonding Force Module
- Chip Heating Module
- Die Flip Module
- Dispenser Module
- Flip Chip Test Module
- Formic Acid Module
- Laser- assisted Bonding Module
- Process Gas Module
- Substrate Heating Module
- Substrate Handling Module
- Ultrasonic Module
- UV Curing Module